

10/585079

AP20 Rec'd PCT/PTO 29 JUN 2006

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?:: NONE
Title:: METHOD, DEVICE AND DIFFRACTION
GRATING FOR SEPARATING
SEMICONDUCTOR ELEMENTS
FORMED ON A SUBSTRATE BY
ALTERING SAID DIFFRACTION
GRATING
Attorney Docket Number:: 292853US2PCT
Total Drawing Sheets:: 3

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: The Netherlands
Status:: FULL CAPACITY
Given Name:: Hendrikus
Middle Name:: Petrus
Family Name:: VAN DER LAAK
City of Residence:: TL Beuningen
Country of Residence:: The Netherlands
Street of Mailing Address:: Platinawerf 20g
City of Mailing Address:: TL Beuningen
Country of Mailing Address:: The Netherlands
Postal or Zip Code of Mailing Address:: NL-6641

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: The Netherlands
Status:: FULL CAPACITY
Given Name:: Hans
Middle Name:: Peter
Family Name:: CHALL
City of Residence:: TL Beuningen
Country of Residence:: The Netherlands
Street of Mailing Address:: Platinawerf 20g
City of Mailing Address:: TL Beuningen
Country of Mailing Address:: The Netherlands
Postal or Zip Code of Mailing Address:: NL-6641

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/NL04/00922	12/29/04

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
03079210.5	Europe	12/30/03	YES

ASSIGNMENT INFORMATION

Assignee Name:: Advanced Laser Separation International
B.V.
Street of Mailing Address:: Platinawerf 20G
City of Mailing Address:: TL Beuningen
Country of Mailing Address:: The Netherlands
Postal or Zip Code of Mailing Address:: NL-6641